



Institute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known	
Sheet		1	of	1	Application Number 10/772,419
					Filing Date February 6, 2004
					First Named Inventor Shunpei YAMAZAKI
					Art Unit 2879
					Examiner Name Not Yet Assigned
					Attorney Docket Number 740756-2712

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
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Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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